	Application No.	Applicant(s)		
Notice of Allowability	10/048,059	NAKAGAWA, TAKASHI		
Notice of Anowability	Examiner	Art Unit		
	Temesghen Ghebretinsae	2611		
The MAILING DATE of this communication appeal claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this apport or other appropriate communication (GHTS. This application is subject to	plication. If not include will be mailed in due	ed course. <b>THIS</b>	
1. X This communication is responsive to amendment filed 3/27	<u>7/07</u> .			
2. $\boxtimes$ The allowed claim(s) is/are <u>4-7</u> .				
3.	been received.  been received in Application No cuments have been received in this  of this communication to file a reply lENT of this application.  itted. Note the attached EXAMINER bes reason(s) why the oath or declarate the submitted.  on's Patent Drawing Review (PTO-	national stage applicate complying with the records of the complying with the complex	quirements	
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the C		hools) of	
Identifying indicia such as the application number (see 37 CFR 1, each sheet. Replacement sheet(s) should be labeled as such in the			Dack) of	
<ol> <li>DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I</li> </ol>	sit of BIOLOGICAL MATERIAL n FOR THE DEPOSIT OF BIOLOGICA	nust be submitted. N AL MATERIAL.	lote the	
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. ☐ Notice of Informal P	atent Application		
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summary	6. ☐ Interview Summary (PTO-413),		
3. Information Disclosure Statements (PTO/SB/08),	Paper No./Mail Date 7.			
Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8.   Examiner's Stateme	ent of Reasons for Allo	wance	
	9. 🗌 Other			
		Temesghen Ghebra Primary Examiner Art Unit: 2611	etinsae	

**Notice of Allowability** 

U.S. Patent and Trademark Office PTOL-37 (Rev. 08-06)